

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: PATENT APPLICATION of:

Inventor(s): JASPER et al.

Appln. No.: 09

Series Code ↑

519,875

Serial No. ↑

Filed: March 6, 2000

Title: OFF-AXIS LEVELLING LITHOGRAPHIC
PROJECTION APPARATUS

Group Art Unit 2851

Examiner: P. Kim

Atty. Dkt. P 257643

M#

P-0128.010-US

Client Ref

R
R C E
EDO NOT USE FOR PROVISIONAL,
DIVISIONAL, CIP OR DESIGN
APPLICATIONS, OR REEXAMINATION OF
PATENTSHon. Commissioner of Patents
Washington, D.C. 20231

Date:

November 8, 2002

Sir:

REQUEST FOR CONTINUED EXAMINATION (RCE) UNDER RULE 114

Please continue the examination of this application.

PREREQUISITESThis application was filed on/after June 8, 1995, is not abandoned, and no court action has been filed, or if filed, it has been terminated.An issue fee **has not been** paid (unless a petition under Rule 313(c)(2) is also being filed -- see item 4 below).**Prosecution has been closed as defined in Rule 114(b).****Reply to any outstanding action must be enclosed or previously filed.**

This application is entitled under Rule 114 to withdrawal of any outstanding finality or of any allowance plus a new action by the Examiner. Consideration on the merits of each submission (e.g., IDS, Amendment, new arguments, new evidence, but not appeal/reply briefs themselves) filed herewith is respectfully requested.

Please consider the following before the next Official Action:

1. Please ☐ enter ☐ do not enter the Amendment filed
2. ☒ The enclosed new Amendment
3. ☐ Consider the arguments in the appeal brief filed _____ and reply brief filed _____
4. ☐ The issue fee has been paid, but this RCE is based on Rule 313(c)(2). See enclosed petition
5. ☐ The enclosed Information Disclosure Statement

☒ IDS Letter
☒ PTO-1449

☐ Cited Appln
☐ Cited Documents

☐ Foreign Search Report/OA
6. ☐ Please suspend action under Rule 103(c) for a period of _____ months (3 mos. Max) for which charge the required \$130 fee (fee code 098) to our Deposit Account (see below).
7. Petition is hereby made to extend the **original** due date of August 8, 2002 to _____ (1 mo) \$110/\$55
cover the date this Request is filed. **PLEASE CHARGE** the requisite fee to our _____ (2 mos) \$400/\$200 + 920
Deposit Account (see below) _____ (3 mos) \$920/\$460
8. **PLEASE CHARGE** the Rule 17(e) (RCE) filing fee of ☒ \$740 (lg. ent.) ☐ \$370 (sm. ent.) plus any deficiency and any other fee due now or later to our Deposit Account No. 03-3975 under Order No. 81468 / 257643

NOTE: Rule 17(e) filing fee Cannot be deferred!
NO CLAIMS FEE REQUIRED unless you are adding claims by box 2 Amendment in which case cover this with PAT-120.

11/12/2002 SMINASS1 00000056 09519875

01 FC:1275 920.00 CH

Pillsbury Winthrop LLP
Intellectual Property GroupP.O. Box 10500
McLean, VA 22102

By Atty: Jean-Paul Hoffman

Reg. No. 42663

(703) 905-2000
Atty/Sec: JH/tmt

Sig:

John P. Darting
John P. DartingFax: (703) 905-2500
Tel: (703) 905-2094**NOTE: File this Request (plus enclosures, if any) in duplicate and with PTO receipt (PAT-103A)**

11/12/2002 SMINASS1 00000056 09519875

02 FC:1801 30331452_1.DOC 740.00 CH

PAT-25 09/02



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

JASPER et al. ✓

Appln. No.: 09/519,875 ✓

Filed: March 6, 2000 ✓

Title: OFF-AXIS LEVELLING IN LITHOGRAPHIC PROJECTION APPARATUS ✓

Confirmation No.: 8797

Group Art Unit: 2851

Examiner: P. KIM

#11/10/C
OK
11/20/02

November 8, 2002

RECEIVED
NOV 15 2002
TECHNOLOGY CENTER 2800

* * * * *

AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION

UNDER 37 C.F.R. § 1.114

Hon. Commissioner of Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated May 8, 2002, the period for reply being extended by a Petition for Three-Month Extension of Time and Request for Continued Examination filed herewith, please amend the above-identified application as follows:

IN THE CLAIMS:

Please enter amended claims 1-8 and 10-12 as follow:

1. (Thrice Amended) A lithographic projection apparatus comprising:
- a first object table constructed and arranged to hold a mask;
 - a second, movable object table constructed and arranged to hold a substrate and having only one reference surface fixed thereon;
 - a projection system constructed and arranged to image an irradiated portion of the mask onto a target portion of the substrate;
 - a positioning system constructed and arranged to move said second object table between an exposure station, at which said projection system can image said mask portion onto said substrate, and a measurement station;

C/✓
11/20/2002 TOKO
01 FC 2002

52961560

52961560